

## EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S1	1	"200293870"	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/06/05 09:17
S2	3	"2002093870"	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/03/06 09:26
S3	1	("5792376").PN.	USPAT; USOCR	OR	OFF	2007/03/06 09:27
S4	2	("4786359"   "5494523").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/03/06 09:28
S5	11	("5792376").URPN.	USPAT	OR	OFF	2007/03/06 09:37
S6	212	etch\$3 same hole\$1 and detection near light and reflect\$6 and depth	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/03/06 09:38
S7	72	etch\$3 same hole\$1 and detection near light and reflect\$6 and depth same hole\$1	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/03/06 09:53
S8	52	S7 and semiconductor	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/03/06 09:52
S9	2	(("5792376") or ("4744660")).PN.	USPAT; USOCR	OR	OFF	2007/03/06 09:52
S10	1	etch\$3 same hole\$1 and detection near light and measur\$3 near3 electrostatic and depth same hole\$1	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/03/06 09:53

## EAST Search History

S11	1	etch\$3 same hole\$1 and detection near light and measur\$3 near3 electrostatic	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/03/06 09:53
S12	3	invalid near policy near detection	US-PGPUB; USPAT	OR	OFF	2007/03/07 08:02
S13	2	Policy near Application near Across near Multiple near Nodes	US-PGPUB; USPAT	OR	OFF	2007/03/07 08:03
S14	7	hole\$1 and irradiat\$3 near3 light and reflectivity and calculat\$3 near2 depth and thickness	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/06/05 10:04
S15	3	S14 and (high near frequency hf) near power	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/06/05 10:37
S16	463	damascene and measuring near3 thickness	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/06/05 10:48
S17	7	S16 and interference near3 intensity	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/06/05 10:40
S18	127	S16 and insulating near film and metal	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/06/05 10:40
S19	18	damascene and measuring near3 etch\$3 near depth	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/06/05 10:49

## EAST Search History

S20	10	S19 and insulating near film	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/06/05 10:50
S21	1	S19 and insulating near film and metal	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/06/05 10:50